



IFW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Attn: OIPE

Akinori KOUKITSU et al.

Group Art Unit: 1722

Application No.: 10/509,177

Docket No.: 121213

Filed: September 27, 2004

For: VAPOR PHASE GROWTH METHOD FOR A1-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR PRODUCING A1-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR

REQUEST FOR CORRECTION OF PALM RECORDS

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached is a photocopy of the original filing receipt on which errors have been corrected in red. These errors are being brought to the attention of the Patent and Trademark Office so that it may correct its records. A Supplemental Application Data Sheet is attached.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

David R. Kemeny
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JAO:DRK/dpw

Date: December 29, 2006

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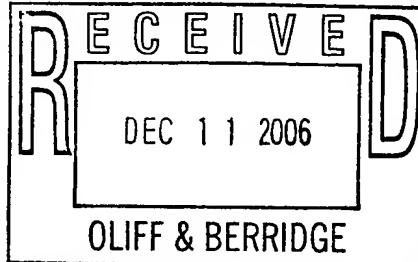
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/509,177	09/27/2004	1722	1092	121213	5	17	5

25944
OLIFF & BERRIDGE, PLC
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CONFIRMATION NO. 5228
CORRECTED FILING RECEIPT

OC000000021524525*

Date Mailed: 12/07/2006

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

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Assignment For Published Patent Application

TOKYO UNIVERSITY AGRICULTURE AND TECHNOLOGY TLO CO., LTD., Koganei-shi, JAPAN
LTD.,

Power of Attorney: The patent practitioners associated with Customer Number 25944.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/04408 04/07/2003

Foreign Applications

JAPAN 2002-106102 04/09/2002

If Required, Foreign Filing License Granted: 09/22/2006

The country code and number of your priority application, to be used for filing abroad under the Paris Convention, is **US10/509,177**

Projected Publication Date: Not Applicable

Non-Publication Request: No

Early Publication Request: No

Title

Vapor phase growth method for ~~a~~ containing III-V group compound semiconductor, and method
and device for producing ~~a~~ containing III-V group compound semiconductor

A1-

Preliminary Class

117

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OLIFF & BERRIDGE, PLC

ATTORNEYS AT LAW

Supplemental Application Data Sheet

Application Information

Application Type:: National Phase
Subject Matter:: Utility
CD-ROM or CD-R:: None
Title:: VAPOR PHASE GROWTH METHOD FOR Al_xA_{1-x}-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR, AND METHOD AND DEVICE FOR PRODUCING Al_xA_{1-x}-CONTAINING III-V GROUP COMPOUND SEMICONDUCTOR
Attorney Docket Number:: 121213
Suggested Drawing Figure::
Total Drawing Sheets:: 5
Small Entity:: No

Applicant Information

Applicant Authority type:: Inventor
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Correspondence Information

Correspondence Customer Number:: 25944

Domestic Priority Information			
Application::	Continuity Type::	Parent Application::	Parent Filing Date::
This Application is a	National Stage of	PCT/JP03/04408	4/7/2003
Foreign Priority Information			
Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	2002-106102	4/9/2002	Yes
Assignee Information			
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